

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	[METHOD OF FABRICATING A POLYSILICON THIN FILM]							
Application Number :								
Date :								
First Named Applicant:	Mr. Mao-Yi Chang							
Confirmation Number:								
Attorney Docket Number:	9003-US-PA							
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<table border="1"><tr><td>Submitted By:</td><td>Elec. Sign.</td><td>Sign. Capacity</td></tr><tr><td>Dr. Belinda Lee Registered Number: 46,863</td><td>/Belinda Lee/</td><td>Agent</td></tr></table>			Submitted By:	Elec. Sign.	Sign. Capacity	Dr. Belinda Lee Registered Number: 46,863	/Belinda Lee/	Agent
Submitted By:	Elec. Sign.	Sign. Capacity						
Dr. Belinda Lee Registered Number: 46,863	/Belinda Lee/	Agent						

Documents being submitted:	Files
us-request	9003-usrequ.xml us-request.dtd us-request.xsl
us-assignment	9003-usassn.xml us-assignment.xsl us-assignment.dtd 9003assignment02.tif 9003assignment01.tif
us-fee-sheet	9003-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
application-body	9003-trans.xml us-application-body.xsl application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblx.dtd 9003us0001.tif 9003us0002.tif 9003us0003.tif 9003us0004.tif 9003us0005.tif 9003us0006.tif
us-declaration	9003declaration01.tif
us-declaration	9003declaration02.tif
Comments	
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However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 9003-US-PA), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw